



Attorney Docket # 5367-47

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Stefan Bader et al.

Serial No.: 10/696,882

Filed: October 30, 2003

For: METHOD FOR DEPOSITING A  
MATERIAL ON A SUBSTRATE  
WAFER

Examiner: G. Nagesh Rao  
Group Art: 1722

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Name of applicant, assignee, or Registered Representative

*Thomas Langer*  
Signature

October 24, 2006  
Date of Signature

Mail Stop: After-Final  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE PURSUANT TO 37 C.F.R. § 1.116**

Sir:

This is a response to the Final Office Action dated July 24, 2006. No new matter has been added.

Remarks/Arguments begin on page 5 of this paper.